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25 Oct 01
R. Talbot

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Hiroshi OGAWA

Appln. No. 09/449,625

Group Art Unit: 2878

Confirmation No.: Not Yet Assigned

Examiner: S. Lee

Filed: November 30, 1999

For: RADIATION IMAGE CONVERSION PANEL AND METHOD OF MANUFACTURING
RADIATION IMAGE CONVERSION PANEL

RECEIVED
OCT 23 2001
TC 2800 MAIL ROOM

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

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